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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

**FURUHATA** 

Serial No.: 10/797,923

Filed: March 10, 2004

Title: SEMICONDUCTOR WAFER,

SEMICONDUCTOR DEVICE, AND PROCESS FOR MANUFACTURING THE

SEMICONDUCTOR DEVICE

Group Art Unit: 2826

Examiner: Thomas L. Dickey

Attorney Docket No.: FUJI:300

Certificate of Filing By Facsimile

I hereby certify that this paper is being transmitted via facelmile to the United States Patent & Trademark

Office, at telephone number: 571-273-8300

DATE: NOVEMBER 28, 2005

Barbare am Dowell BARBARA A. MCDOWELL

## AMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 37 CFR § 1.116

COMMISSIONER FOR PATENTS P.O. Box 1450 ALEXANDRIA, VA 22313-1450 ...

Sir.

This communication is responsive to the Office Action dated July 27, 2005, concerning the above-referenced patent application. Applicant hereby petitions for a two-month extension under 37 C.F.R. §1.136, so that the period for response is extended to expire on November 27, 2005 (a Sunday). Applicant authorizes payment of the extension fee of \$450.00 to Deposit Account No. 18-2056. The Commissioner also is hereby authorized to charge any additional fees which may be required regarding this application under 37 C.F.R. §§ 1.16-1.17 to Deposit Account No. 18-2056, including any additional extension of time needed for timely acceptance of papers submitted herewith.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows:

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